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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Jia-Chong HO et al. Confirmation No: 2765
Appl. No. : 10/730,073
Filed : December 9, 2003
Title : COMPOUND SEMICONDUCTOR MATERIAL AND METHOD
FOR FORMING AN ACTIVE LAYER OF A THIN FILM
TRANSISTOR DEVICE

TC/A.U. : 2822
Examiner : T. Y. Tran

Docket No.: HOJI3001/REF
Customer No: 23364

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Applicants request that the period for response to the outstanding official action in this case be extended pursuant to 37 CFR 1.136 (a) for THREE (3) months to April 11, 2007.

The fee set in 37 CFR 1.17(a)(3) for a three month extension of time is \$1,020.00 and a check in this amount is submitted herewith. Please charge any additional fee required for this extension to Deposit Account No. 02-0200.

Respectfully submitted,

BACON & THOMAS, PLLC

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April 11, 2007